



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: LEE, Ho
Assignee: Samsung Electronics Co., Ltd.
Title: CHEMICAL VAPOR DEPOSITION APPARATUS
Application No.: 10/750,023 Filing Date: December 31, 2003
Examiner: Jeffrie Robert Lund Group Art Unit: 1763
Docket No.: AB-1350 US Confirmation No.: 9344

San Jose, California
July 20, 2006

Mail Stop Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

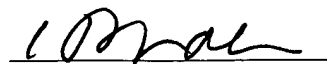
PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicants respectfully petitions for a one-month extension of time within which to file the Response to the Office Action mailed on March 23, 2006 thus allowing the undersigned until July 20, 2006 to file a Response.

Please charge the amount of \$120.00 set forth in the enclosed transmittal letter.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 20, 2006.


Attorney for Applicant(s) 
Date of Signature

Respectfully submitted,



Hugh H. Matsubayashi
Attorney for Applicants
Reg. No. 43,779

LAW OFFICES OF
MacPherson, Kwok, Chen &
Heid LLP
1762 Technology Drive
Suite 226
San Jose, CA 95110
Telephone: (408) 392-9520
Fax: (408) 392-9262

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